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AF EFW  
AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 2827  
PATENT APPLICATION

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q67536

Masamoto TAGO

Appln. No.: 09/998,243

Group Art Unit: 2827

Confirmation No.: 6291

Examiner: Lourdes C. Cruz

Filed: December 03, 2001

For: COMPACT SEMICONDUCTOR DEVICE CAPABLE OF MOUNTING A PLURALITY  
OF SEMICONDUCTOR CHIPS WITH HIGH DENSITY AND METHOD OF  
MANUFACTURING THE SAME

**AMENDMENT UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 19, 2004, please amend the above-identified  
application as follows on the accompanying pages.